ISSUE CLASSIFICATION

Class | Subclass

PATENT MASTER

U.S. **UTILITY** Patent Application

	O.I.P.E.	PATENT DATE
SCANNED	Q.A. mc	

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/505627	F	250	55	2475	

APPLICANTS

Nobuhiro Ito

TITLE

Manufacturing method of electron beam apparatus and spacer, and electron beam apparatus

PTO-2040
12/99

ISSUING CLASSIFICATION

ORIGINAL			CROSS REFERENCE(S)						
CLASS	**SUBCLASS**	**CLASS**	**SUBCLASS (ONE SUBCLASS PER BLOCK)**						
INTERNATIONAL CLASSIFICATION									
					☐ Continued on Issue Slip Inside File Jacket			

☐ **TERMINAL DISCLAIMER**	**DRAWINGS**			**CLAIMS ALLOWED**	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
☐ The term of this patent subsequent to _____ (date) has been disclaimed.				**NOTICE OF ALLOWANCE MAILED**	
	(Assistant Examiner)		(Date)		
☐ The term of this patent shall not extend beyond the expiration date of U.S Patent. No. _____					
				ISSUE FEE	
_____				Amount Due	Date Paid
_____	(Primary Examiner)		(Date)		
☐ The terminal ____months of this patent have been disclaimed.				**ISSUE BATCH NUMBER**	
	(Legal Instruments Examiner)		(Date)		

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